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Applicant: Hiroshi KAJIYAMA, et al.

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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
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FOREIGN PATENT DOCUMENTS

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							Yes	No
	AK							
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

D.D.	AQ	WATANABE, et al. "MgO Material used as protective Layer for PDP (Plasma Display Panels)" Monthly Journal, February 2000						
D.D.	AR	UETANI, et al. "Ion-Plating Desposition of MgO Thin Films" Materials Transactions, 2001						
D.D.	AS	UETANI, et al. "Ion-Plating Deposition of MgO Protective Layer for AC-Plasma Display Panels" Materials Research Society, 2001						
D.D.	AT	UETANI, et al. "Secondary Electron Emission Characteristics of MgO Thin Films Prepared by an Advanced Ion-Plating Method" Materials Transactions, 2001						

EXAMINER *[Signature]*

DATE CONSIDERED 12/19/02

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